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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): Stefan THIEM et al.

Serial No.:

_unknown 09/ 93+

Filing Date:

8.16.01

Title:

APPARATUS FOR TREATING OBJECTS

Group Art Unit: anknown

Examiner: unknown

Atty Ref: LNUP: 104_US

INFORMATION DISCLOSURE STATEMENT

Box Patent Application Commissioner for Patents Washington, D.C. 20231

Honorable Sir:

This Information Disclosure Statement is submitted within three months of the filing date of the above-identified application or before mailing of a first Office Action in compliance with 37 C.F.R. §§ 1.56 and 1.97(b). Record is made of published art listed in the attached Form PTO-A820, and a copy of the cited reference is enclosed for consideration during prosecution of the above-identified patent application.

Respectfully submitted,

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Dated: August 16, 2001

	-	DRMATION DISCLOSURE CITATION (Use several sheets if necessary)			Docket Number (Opt LNUP.	US_	Application Number (000		
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